

Notice of References Cited	Application/Control No. 10/584,095	Applicant(s)/Patent Under Reexamination SCHEUCHER, HEIMO	
	Examiner Cuong Q. Nguyen	Art Unit 2811	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0211700	11-2003	Leung et al.	438/401
*	B	US-6,114,072	09-2000	Narimatsu, Koichiro	438/462
	C	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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